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	Filing Date	Jan 17, 2002
	First Named Inventor	Sarfaty, Moshe
	Group Art Unit	2881
	Examiner Name	Unknown
Total Number of Pages in This Submission	Attorney Docket Number	4734/AMI-00-04

ENCLOSURES (check all that apply)		
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Applicant: Sarfaty, et al.

PATENT APPLICATION

Serial No.: 10/053,357

Group Art Unit: 2881

Filing Date: January 17, 2002

Examiner: Unknown

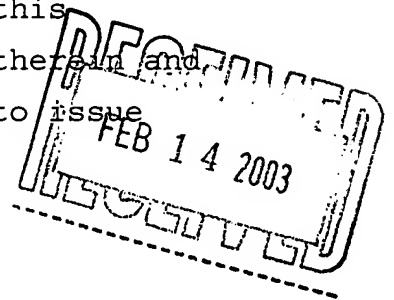
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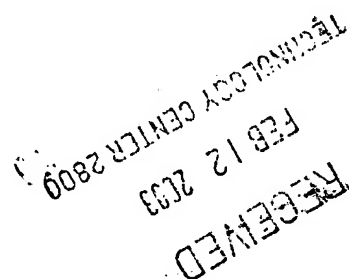
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The following information is submitted in compliance with Applicants' duty of disclosure under 37 C.F.R. § 1.56. Form PTO-1449 and a copy of each reference recited below accompanies this document. It is respectfully requested that the cited information be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.



ISSUED PATENTS

<u>Patent Number</u>	<u>Inventor</u>	<u>Grant Date</u>
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FOREIGN PATENT DOCUMENTS

<u>Document Number</u>	<u>Inventor</u>	<u>Publication Date</u>
EP 0867775	Kaisha	Sep. 30, 1998
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NON-PATENT DOCUMENTS

Uchida et al. A mask-to-wafer alignment gap setting method for x-ray lithography using gratings, J. Vac. Sci. Technol. B 9(6), Nov/Dec 1991, pp. 3202-3206.

Haisma et al. Mold-assisted nanolithography: A process for reliable pattern replication, J. Vac. Sci. Technol. B 14(6), Nov/Dec 1996, pp. 4124-4128.

White et al. Novel alignment system for imprint lithography, J. Vac. Sci. Technol. B 18(6), Nov/Dec 2000, pp. 3552-3556.

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Respectfully Submitted,



Kenneth C. Brooks
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